

O P E INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		Attorney Docket No.: 046124-5388	Serial No.: 10/537,509
DEC 08 2005 REC'D BY PTO FORM 1449		Applicants Furnitsugu FUKUYO et al.	Page 1 of 2
		Filing Date: June 3, 2005	Confirmation No.: 4531

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Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date
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JG	5,254,833	Oct. 19, 1993	OKIYAMA			
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JG	5,211,805	May 18, 1993	SRINIVASAN			

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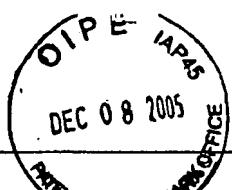
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Examiner	/Jairus Greene/	Date Considered	05/18/2007
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Attorney Docket No.
46884-5388

Application No.: 10/537,509

Applicants: Eumitsugu FUJIKIYO et al

Filing Date: June 3, 2005

Group Art Unit: Unassigned

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JG	Tooling Machine Series, "Laser Machining" published by Taiga Shuppan Inc., 1990, pp. 91-96, including English language translation
JG	"Stealth Dicing, It's Principles and Features: A Technology Most Suitable for Dicing Very Thin Semiconductor Wafers" published by Takaoka Hidetsugu, Electronic Material No. 9, 2002, pp. 17-21, including English language translation
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/Tairus Greene/

Date Considered

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Group Art Unit: 2812

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JG	5,211,805	May 18, 1993	Srinivasan	-	-	

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JG	10-305420	November 17, 1998	JP			Abstract		
JG	04-111800	April 13, 1992	JP			Abstract		
JG	09-017756	January 17, 1997	JP			Abstract		
JG	07-037840	February 7, 1995	JP			Abstract		
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Examiner <i>/Jairus Greene/</i>	Date Considered <i>05/18/2007</i>
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JG	61-121453	Sept. 6, 1986	Japan			X (abstract)	
JG	2005-001001	Jan. 6, 2005	Japan			X (abstract)	
JG	2003-334812	Nov. 25, 2003	Japan			X (abstract)	
JG	2000-042764	Feb. 15, 2000	Japan			X (abstract)	
JG	05-335726	Dec. 17, 1993	Japan			X (abstract)	
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JG	2003-338467	Nov. 28, 2003	Japan			X (abstract)	
JG	11-163097	June 18, 1999	Japan			X (abstract)	
JG	06-188310	July 8, 1994	Japan			X (abstract)	
JG	WO 03/076118 A1	Sept. 18, 2003	PCT			X (abstract)	
JG	2002-192369	Oct. 7, 2002	Japan			X (abstract)	
JG	2005-159378	June 16, 2005	Japan			X (abstract)	
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JG	JP 4-188847	Jul. 7, 1992	Japan			Yes	Abstract
JG	JP 7-263382	Oct. 13, 1995	Japan			Yes	Abstract
JG	JP 9-263734	Oct. 7, 1997	Japan			Yes	Abstract
JG	JP 2006-128723	May 18, 2006	Japan			Yes	Abstract
JG	JP 2002-192367	Jul. 10, 2002	Japan			Yes	Abstract
JG	JP 2000-042764	Feb. 15, 2000	Japan			Yes	Abstract
JG	JP 5-335726	Dec. 17, 1993	Japan			Yes	Abstract
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